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<th>Robust simulation methodology for surface-roughness loss in interconnect and package modelings</th>
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<td>Author(s)</td>
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Abstract—In multigigahertz integrated-circuit design, the extra energy loss caused by conductor surface roughness in metallic interconnects and package models is much more than the ever before and demands explicit consideration for accurate prediction of signal integrity and energy consumption. Existing techniques based on analytical approximation, despite simple formulations, suffer from restrictive valid ranges, namely, either small or large roughness/frequencies. In this paper, we propose a robust and efficient numerical-simulation methodology applicable to evaluating general surface roughness, described by parameterized stochastic processes, across a wide frequency band. Traditional computation-intensive electromagnetic simulation is avoided via a tailored scalar-wave modeling to capture the power loss due to surface roughness. The spectral stochastic collocation method is applied to construct the complete statistical model. Comparisons with full wave simulation as well as existing methods in their respective valid ranges then verify the effectiveness of the proposed approach.

Index Terms—Interconnect, power loss, rough surface, scalar-wave modeling (SWM), spectral stochastic collocation.

I. INTRODUCTION

SURFACE ROUGHNESS in metal conductors of interconnects and microelectronic packages is sometimes due to process variations in fabrication and, more frequently, artificial roughening processes, e.g., electronic deposition and chemical etching, to promote interfacial adhesion between dielectrics and conducting materials. Fig. 1(a) shows the cross section of a metal trace with roughness around it, while Fig. 1(b) shows an atomic-force microscopy (AFM) for the top view of a printed circuit board (PCB) interconnect demonstrating the 3-D rough surface. It has been reported by measurements that the surface-profile variation in roughened copper foil can cause an increase of resistivity by a factor of two to three in microwave frequencies [1]. Recent experimental studies can be found in [2] and [3]. Such impact on resistivity breaks the predictive capacity of classical high-frequency relationship $R_f \propto \sqrt{f}$ for the frequency-dependent resistance $R_f$. With the ever-increasing signaling rate, particularly in high-speed communications of multiprocessor architectures, an accurate estimation of rough-surface effect is imperative for improved prediction of insertion loss, signal integrity, and thermomechanical reliability in interconnect-aware design methodologies and tools.

Attempts to evaluate the roughness-induced loss by incorporating surface variations directly into specified field solvers have been made, e.g., in [4]. However, the computation is highly expensive due to the huge problem size resulting from numerical simulation with surfaces of the whole structure. A more viable way to scale the conducting loss by a frequency-dependent factor that quantifies the local impact of surface roughness, which can as well be used in ordinary simulators to scale the reference values of resistance and inductance extracted from smooth-surface conductor to generate more accurate simulation models. In addition, the current-density-independent loss-scaling factor can be reused for different interconnect structures with similar rough-surface characteristics, e.g., those produced by the same processing techniques.

Most existing techniques simply calculate this factor in a closed-form manner. For instance, the guideline model in industrial practice, Hammerstad formula, estimates the loss-scaling factor can be reused for different interconnect structures with similar rough-surface characteristics, e.g., those produced by the same processing techniques.

More practical models for 3-D surface roughness include the second-order small perturbation method (SPM2) [6] (which models the surface roughness by stochastic processes) and the hemispherical boss modeling (HBM) [7] (which models surface irregularities as size-controlled hemispherical bosses distributed, regularly or randomly, on a flat plane). Nevertheless, the efficiency gain of closed-form models comes at the cost of applicability, namely, both SPM2 and HBM suffer from restricted valid regions. More specifically, SPM2 requires the root mean-square (rms) height of roughness, and the surface...
slope are small to validate the presumption of “perturbation,” which limits its applicability to small roughness and low-to-medium clock frequencies. To the opposite of SPM2, HBM primarily works under the scenarios with large roughness or very high frequencies, where the skin depth is small compared with the radii of the bosses. Such restrictiveness demands a careful selection of proper closed-form techniques for given scenarios, and undesirable, or even impossible, model switches if simulation domain exceeds the valid region of a single technique. Fig. 2 roughly shows the corresponding valid regions of SPM2 and HBM w.r.t. the ratio of roughness and skin depth for fixed roughness with varying and fixed frequencies with varying roughness, although, in general, there is not a solid boundary for one’s valid region and the validity of a given model has to be judged within the context. Consequently, the figure suggests that there is still a lack of efficient simulation methods for evaluating surface-roughness loss at the intermediate frequency/roughness ranges where the skin depth has the same order of dimension as the roughness, which is often the case in practice.

Furthermore, surface roughness is usually regarded as a source of variation in stochastic analysis of interconnect and packaging simulation. However, the closed-form techniques can only calculate the mean value of loss-scaling factor and cannot be used to compute the standard deviation or complete distribution of the factor. This makes it difficult, if not impossible, to generate models compatible with postprocessing stochastic-model order reduction and statistical timing-analysis tools [8], [9], most of which require the availability of high-order statistics. A numerical-evaluation approach of loss-scaling factor allowing the acquisition of second-order variance has been proposed by [10] using direct stochastic integral equation (IE). However, the technique is only applicable to 2-D surface model assuming a constant magnetic field on the surface, which largely restricts its accuracy, since practical problems are generally 3-D with dynamic magnetic field.
To address these problems, namely, lack of generally valid higher order statistical models, we employ a numerically robust methodology, called scalar-wave modeling (SWM), to simulate the impact of 3-D surface roughness with diverse roughness patterns over a wide frequency range. While the preliminary idea of SWM for rough-surface loss analysis was first proposed in [11] by us, it is further developed into a more accurate and usable form utilizing triangular discretization of rough surfaces. New results are presented regarding the limitations of SPM2 and HBM, and comparison against electromagnetic (EM) vectorial modeling confirms the efficacy of the SWM approach. In particular, in SWM, a rough surface is modeled by a parameterized stochastic process. The complicated EM problem is transformed into a simplified scalar representation by regarding the EM wave as a scalar energy flux. In this way, the extra loss caused by surface roughness can be approximated by the amount of energy absorbed by the rough surface upon which the scalar flux is incident. The surface IEs thus established are numerically solved by the method of moments (MOM). An efficient stochastic solver, spectral stochastic collocation method (SSCM) [12], is applied to generate the second-order statistical model of the loss-scaling factor so that conventional (expensive) Monte Carlo (MC) simulations can be avoided. This paper is organized as follows. Section II reviews the characterization of a 3-D random rough surface via stationary stochastic processes and the formulas of SPM2 and HBM. Formulation and solution of the proposed SWM are detailed in Section III. Verification against vectorial EM modeling is given in the same section. Numerical comparisons with existing techniques in their respective valid regions are then conducted in Section IV to verify the effectiveness of SWM. Finally, Section V draws the conclusion.

II. BACKGROUND REVIEW

For the 3-D random rough surface of a conductor, we describe the surface height \(h(\mathbf{r}_{ij})\) as a stationary stochastic process, where \(\mathbf{r}_{ij} = (x, y)\) falls on the mean plane. A stochastic process is generally characterized by the probability density function (PDF) and the spatial correlation function (CF) \(C(\mathbf{r}_{i,j}, \mathbf{r}_{j,j})\). Without loss of generality, we use the Gaussian PDF

\[
\text{PDF}(h(\mathbf{r}_{ij})) = \frac{1}{\sqrt{2\pi}\sigma} \exp \left( -\frac{h^2(\mathbf{r}_{ij})}{2\sigma^2} \right)
\]  

(2)

in this paper associated with different CFs. Here, \(\sigma\) is the standard deviation, and the mean plane is on \(h = 0\).

An important feature of this characterization is that the stochastic process parameters, e.g., \(\sigma\) and \(C\), can be quantitatively extracted from a real interconnect surface by measuring surface height as a function of position [13]. Subsequently, different surface roughness, in reality, can be reproduced and simulated by properly parameterizing the stochastic processes. Fig. 3 shows a simulated 3-D random rough surface with the common Gaussian CF, \(C(d) = \sigma^2 \exp(-d^2/\eta^2)\), where \(d = |\mathbf{r}_{i,j} - \mathbf{r}_{j,j}|\) and \(\eta\) is the correlation length. In general, a larger \(\sigma\) or a smaller \(\eta\) implies a rougher surface.

The closed-form SPM2 and HBM techniques are succinctly reviewed. On one hand, SPM2 [6] assumes small surface height and slope, and uses the aforementioned stochastic surface modeling for calculating the mean value of loss-scaling factor by

\[
\frac{P_r}{P_s} = 1 + \frac{2\sigma^2}{\delta^2} - \frac{2}{\delta} \int dk_x dk_y W(k_x, k_y) \text{Re}\left( \frac{2j\delta - k_x^2 - k_y^2}{\omega \mu \epsilon} \right)
\]

(3)

where the spectral density function \(W(k_x, k_y)\) is the Fourier transform of the CF. On the other hand, HBM [7] models surface roughness as conducting protrusions and calculates the loss-scaling factor by

\[
\frac{P_r}{P_s} = \text{Re}\left[ \frac{4\pi}{\delta^2} \left(\frac{\omega}{\omega_0}\right)^3 \left( \alpha(1) + \beta(1) \right) \right] + \frac{\mu_0 \delta}{4} \left( A_{\text{tile}} - A_{\text{base}} \right)
\]

(4)

where \(\omega = 2\pi f\), \(k_1 = \omega\sqrt{\mu\epsilon_1}\) is the wavenumber, and \(\Omega = \sqrt{\mu/\epsilon_1}\) (\(\epsilon_1\) being the permittivity) denotes the wave impedance of the upper medium. Here, \(\alpha(1)\) and \(\beta(1)\) are the approximated scattering coefficients which can be analytically evaluated only when \(\delta\) is small compared with the size of the protrusion. \(A_{\text{tile}}\) and \(A_{\text{base}}\) are the tile areas of the plane surrounding the protrusion and the base area of the hemisphere with equal volume to the protrusion, respectively.

SPM2 generally breaks down as the dimensions of roughness increase, particularly, the slope of rough surface becomes large. HBM is a gross assumption as surface roughness in real interconnects is substantially diverse, which is difficult to be modeled by simple bosses (see Section IV where numerical examples demonstrate the inadequacy of the hemispherical modeling in HBM). Moreover, HBM becomes invalid when \(\delta\) is close to or greater than the height of protrusion, since, in this case, the energy dissipated by a protrusion is even smaller than that by a flat plane with an area equal to the base of the protrusion [7]. Numerical examples are given in Section IV to confirm the universal applicability of the proposed SWM approach versus the restrictive natures of SPM2 and HBM.
III. SWM

In principle, EM wave theory can be used to rigorously determine the field scattered or absorbed by a conducting body, which has been extensively studied for decades [14]. Direct application of numerical EM simulation to predict surface-roughness loss in microscopic interconnects, however, faces the following difficulties.

1) The wavelength in dielectrics (on the order of centimeters) is large compared with the dimension of a conductor surface (on the order of micrometers). This corresponds to the well-known low-frequency problem in traditional EM scattering from metallic objects, in which the numerical solution of IE can become unstable due to the dominant impact of hypersingular integral operator [15]. Remedies of such problem include using high-order loop star basis or modifying the integral operators, all of which will significantly increase the complexity of calculation.

2) The computation is intensive if direct EM formulation is applied due to its vectorial nature, particularly when a fine discretization of the surface is needed to properly capture the details of surface variation. The situation becomes worse if the low-frequency problem (requires higher order basis or operator) and random surface modeling (requires multiple sampling) are taken into account.

To balance the cost and performance, we choose scalar-wave theory instead of EM wave theory to formulate the energy loss caused by surface roughness in interconnects and packaging. SWM has long been used as a simplifying substitute for vectorial EM wave to predict wave behavior and observe important phenomena in scattering problems [16]. It has been shown that the results of SWM are well correlated to that from EM wave modeling in many cases, particularly when the detailed field distribution is not required [17].

To formulate the problem with SWM, we consider a general two-medium case, where the upper half-space of a rough interconnect is filled by dielectrics (medium 1) with electrical parameters $\varepsilon_1$, $\mu_1$, and wavenumber $k_1$ as in (4), and the lower half by conducting material (medium 2) with $\rho_2$, $\mu_2$, and $k_2 = (1 + j)/\delta$. One considers a scalar plane wave normally impinging on the rough surface $\psi_{in}(\bar{r}) = \exp(-jk_0z)$, where $\bar{r} = (x, y, z)$; then the wave functions $\psi_i$, $i = 1, 2$, in both media obey the 3-D Helmholtz equation

$$ (\nabla^2 + k_i^2) \psi_i = 0. \quad (5) $$

On applying the Green’s second identity, two coupled surface IEs can be established [17]

$$ \int_S d\bar{s} \hat{n}' \cdot [G_1(\bar{r}, \bar{r}') \nabla \psi_1(\bar{r}') - \nabla' G_1(\bar{r}, \bar{r}') \psi_1(\bar{r}')] $$

$$ + \psi_1(\bar{r}) = \psi_{in}(\bar{r}), \quad \bar{r}, \bar{r}' \in S \quad (6a) $$

$$ \int_S d\bar{s} \hat{n}' \cdot [G_2(\bar{r}, \bar{r}') \nabla' \psi_2(\bar{r}') - \nabla' G_2(\bar{r}, \bar{r}') \psi_2(\bar{r}')] $$

$$ - \psi_2(\bar{r}) = 0, \quad \bar{r}, \bar{r}' \in S \quad (6b) $$

where $\hat{n}'$ is the unit surface normal vector pointing outward at $\bar{r}'$, $\nabla'$ is the gradient w.r.t. $\bar{r}'$, and $G_i$, $i = 1, 2$, is the scalar Green’s function in the $i$th medium with

$$ G_i(\bar{r}, \bar{r}') = \frac{\exp(ik_i|\bar{r} - \bar{r}'|)}{4\pi|\bar{r} - \bar{r}'|}. \quad (7) $$

It should be noted that, unlike electric or magnetic field, the scalar field $\psi$ (including $\psi_1$, $\psi_2$, and $\psi_{in}$) does not have a physical meaning and, intuitively, can be interpreted as the velocity potential of a scalar energy flux. Analogously, one can view the scalar flux as a sound wave in which $\psi$ corresponds to the sound pressure (linearly proportional to the acoustic-velocity potential) [18].

The essence of our formulation is to calculate the amount of energy absorbed by a rough surface subjected to a given incident acoustics-like scalar flux, which serves as an approximation of the real EM energy absorbed by the same surface. The purpose of such transformation is to achieve a balance between the extreme efficiency of closed-form techniques and the extreme accuracy of rigorous EM simulation, leading to a tradeoff that enjoys simple implementation and fast computation while still preserving sufficient simulation capacity for generic cases.

A. Continuous Boundary Condition for Scalar Waves

To solve (6), an appropriate boundary condition must be established to relate the field unknowns in the two media. Considering our goal to approximate an EM wave by a scalar wave, this boundary condition should properly model the physical behavior of a real EM field transmitting from dielectrics into a highly conducting medium. Since conventional boundary conditions, e.g., Dirichlet ($\psi = 0$), Neuman ($\hat{n} \cdot \nabla \psi = 0$), or acoustic impedance ($\alpha \psi + b \hat{n} \cdot \nabla \psi = 0$), are insufficient to capture the continuity of EM field across the rough boundary, a new boundary condition tailored for SWM is derived in the following by exploiting the energy equivalence between EM wave and acoustic wave as a representative of scalar wave.

As indicated in [6] and [7], the distribution of EM field near the surface of practical quasi-transverse EM interconnect structures is similar to that induced by an incident transverse-magnetic wave. Since the wavelength in dielectric is much larger than the scale of surface roughness, the magnetic field $\vec{H}$ very close to the surface can be approximated by its tangential component $\hat{H}_t$. If we associate $\psi$ with a physical meaning as the magnitude of $\hat{H}_t$, the following relationship for $\hat{H}_t$, as well as the tangential electromagnetic field $E_t$ holds:

$$ \vec{H} \approx \hat{H}_t = \hat{t}_H \psi \quad (8) $$

$$ \vec{E}_t = \hat{t}_E \left[ \frac{1}{j\omega \epsilon} \left( \psi \hat{n} - \hat{n} \cdot \nabla \psi \right) \right] \quad (9) $$

where $\hat{t}_H$ and $\hat{t}_E$ refer to the unit tangential vectors for $\vec{H}$ and $E$, respectively, and $\psi = |\hat{n} \times \hat{n} \times (\nabla \times \hat{H}_t)|$. The detailed derivation of (9) is given in the Appendix. The validity of such association can be shown by calculating the approximated
intensity of EM energy (Poynting vector) normal to the rough surface by
\[
\mathbf{S}_\text{EM} \approx \hat{n} \cdot \frac{1}{2} \text{Re} \left\{ \mathbf{E}_t \times \mathbf{H}_t^* \right\} = \frac{1}{2} \text{Re} \left\{ \hat{n} \cdot (\hat{\mathbf{E}}_t \times \hat{\mathbf{H}}_t^*) \right\} = \frac{1}{2} \text{Re} \left\{ \frac{1}{j\omega} [\psi^* + \hat{n} \cdot \nabla \psi] \right\} = \frac{1}{2} \text{Re} \left\{ \frac{1}{j\omega} [\psi^* \hat{n} \cdot \nabla \psi] \right\}
\]
and recognizing its consistency with the acoustic intensity normal to the rough surface calculated by [18]
\[
\mathbf{S}_\text{Acous} \approx \hat{n} \cdot \frac{1}{2} \text{Re} \left\{ p^* \frac{1}{j\omega \rho_m} \nabla p \right\} = \frac{1}{2} \text{Re} \left\{ \frac{1}{j\omega \rho_m} \hat{n} \cdot \nabla \psi \right\}
\]
where \( p \) refers to the sound pressure and \( \rho_m \) the material density of the medium. Here, we assume \( \epsilon \) is real. More specifically, it means that with the equivalence between \( \psi \) and \( |\mathbf{H}_t| \) at the boundary, the intensity of energy flux of an EM wave can be well approximated by that of a scalar wave. Note that the earlier derivation is only valid for regions very close to the boundary, and, for other regions, the \( \hat{\mathbf{E}}_t \) and \( \hat{\mathbf{H}}_t \) in (10) should be replaced by \( \mathbf{E} \) and \( \mathbf{H} \), respectively. Finally, recalling the continuity of tangential fields across the boundary \( H_{t1} = H_{t2}, \hat{E}_{t1} = \hat{E}_{t2} \), we have the following boundary conditions for \( \psi \) and \( \hat{n} \cdot \nabla \psi \):
\[
\psi_1(\hat{r}) = \psi_2(\hat{r}), \quad \hat{n} \cdot \nabla \psi_1(\hat{r}) = (1 - \gamma) \nu(\hat{r}) \psi_2(\hat{r}) + \gamma \hat{n} \cdot \nabla \psi_2(\hat{r})
\]
where \( \gamma = \epsilon_1/\epsilon_2 = -j\omega \epsilon_1 \rho \).

### B. Doubly Periodic Surface Assumption

Equation (6) should be fundamentally solved on the whole ensemble of realistic conductor surfaces, which, however, is computationally prohibitive. However, significant simplification is achievable via exploiting the particular properties of rough-surface problems in interconnect and packaging simulations. There are three important physical observations.

1) The impact of surface roughness on resistive loss is local, i.e., mutual coupling between surface roughness on separate conductors or different surfaces of one conductor is negligible.

2) The roughness is globally uniform for conductor in the same layers such that a global factor of loss enhancement can be obtained from local analysis. For nonuniform (e.g., piecewise-uniform) rough structures, local loss-scaling factors can be determined and submitted to 2-D field-solvers to obtain self-consistent parasitic parameters [13].

3) The spatial correlation of roughness is small compared with the geometry of conductor surfaces, which means that the surface contains, for random modeling, many peaks and valleys, or for HBM, a large number of bosses. This has been confirmed by physical measurements [7].

In light of these observations, a doubly periodic condition [17] is applied to restrict the investigation domain to within a small patch of the whole surface by enforcing \( f(x + pL, y + qL) = f(x, y) \), where \( L \) is the periodical length and \( p \) and \( q \) are integers. Note that such an assumption is only valid for surface-based local extraction of global factor and does not apply to global simulation involving volume domain as in [4]. Recalling the continuity relation (12), (6) becomes
\[
\psi(\hat{r}) + \int_{L^2} \mathfrak{d}r' \left[ \left( -\frac{\partial G^p_P(\hat{r}, \hat{r}')}{\partial \hat{n}} + (1 - \gamma)(1 - \nu) \right) \psi(\hat{r}') + \gamma G^p_P(\hat{r}, \hat{r}') u(\hat{r}') \right] = \psi_{in}(\hat{r})
\]
and
\[
\psi(\hat{r}) + \int_{L^2} \mathfrak{d}r' \left[ \frac{\partial G^p_P(\hat{r}, \hat{r}')}{\partial \hat{n}} \psi(\hat{r}') - G^p_P(\hat{r}, \hat{r}') u(\hat{r}') \right] = 0
\]
where \( L^2 \) denotes the investigation patch with an area of \( L \times L \), \( \psi = \psi_1 = \psi_2 \), and \( u = \sqrt{1 + f_z^2 + f_y^2 \hat{n} \cdot \nabla \psi_2} \) with \( f_x = \partial f/\partial x \). The periodic Green’s function and its normal derivative are
\[
G^p_P = \sum_{p = -\infty}^{\infty} \sum_{q = -\infty}^{\infty} \exp \left( j k \sqrt{r^2 - \hat{r}'^2 - 2 \hat{r}' \cdot \hat{r} - 2 \hat{r} \cdot x} \right) \mathfrak{d}x
\]
\[
\frac{\partial G^p_P(\hat{r}, \hat{r}')}{\partial \hat{n}} = \sqrt{1 + f_z^2 + f_y^2} \hat{n} \cdot \nabla G^p_P.
\]

The periodic Green’s function in (14) can be efficiently computed by the Ewald method [19], which requires very few terms to converge.

Unlike the simplifying rectangular patches used in [11], plane triangular patches are adopted here to discretize the rough surface, which is more capable of conforming to rough surface with arbitrary curvatures and, thus, helps to improve the accuracy for large roughness. The IE (13) is solved by MOM with point matching, which results in the following matrix equation:
\[
ZJ = J_{in}
\]
where
\[
Z = \begin{bmatrix} A_1 + (1 - \gamma) B_1 V & \gamma B_1 \\ A_2 & B_2 \end{bmatrix}, \quad J = \begin{bmatrix} \Psi \\ U \end{bmatrix}
\]
and
\[
J_{in} = \begin{bmatrix} \Psi_{in} \\ 0 \end{bmatrix}.
\]
The details of the matrix elements in \( A_1, B_1, \) and \( V \) are shown in (16)–(18), respectively
\[
A_1(m, n) = \left\{ \begin{array}{ll} \frac{1}{2} + (-1)^i \int_{\Delta m} \mathfrak{d}r \frac{\partial G_P^p(\hat{r}, \hat{r}')}{\partial \hat{n}_m}, & m = n \\ (-1)^i \int_{\Delta m} \mathfrak{d}r \frac{\partial G_P^p(\hat{r}, \hat{r}')}{\partial \hat{n}_m}, & m \neq n \end{array} \right.
\]
\[
B_i(m, n) = \left\{ \begin{array}{ll} \frac{(-1)^{i+1}}{2} \int_{\Delta m} \mathfrak{d}r G_P^p(\hat{r}, \hat{r}') \Delta s_n, & m = n \\ (-1)^i \int_{\Delta m} \mathfrak{d}r G_P^p(\hat{r}, \hat{r}') \Delta s_n, & m \neq n \end{array} \right.
\]
\[
V(m, n) = \begin{bmatrix} \hat{n}_m \times \hat{n}_m \times (\nabla \times \mathbf{t}_{H_m}) \\ 0 \end{bmatrix}, \quad m = n, \quad m \neq n
\]
where \( \Delta s_n \) is the area of the \( n \)th triangular patch projected on the mean plane.
Equation (15) can be efficiently solved in $O(N \log(N))$ complexity, where $N$ is the number of discretized elements, with numerical solvers such as the fast-Fourier-transform-based iterative method [20] and the UV-multilevel partitioning method [21]. Once the scalar surface unknowns $\psi$ and $u$ are solved, the energy of the scalar wave absorbed by the conductor beneath the investigation patch is computed in an analogous form as (11)

$$
P_r = \frac{1}{2} \int \int \nabla \psi(\bar{r}) \nabla^* \psi(\bar{r}) \, dv
$$

$$
= \frac{1}{2} \int \int \operatorname{Re}\left\{ \psi^*(\bar{r}) \frac{\partial \psi(\bar{r})}{\partial n} \right\} \, ds
$$

$$
= \frac{1}{2} \int \int \operatorname{Re}\left\{ \psi^*(\bar{r}) \frac{\partial \psi(\bar{r})}{\partial n} \right\} \, ds
$$

$$
= \frac{1}{2} \int \int \operatorname{Re}\left\{ \psi^*(\bar{r}) u(\bar{r}) \right\} \, dr
$$

where the second equality results from applying the Green’s first identity and (5) and the third equality is due to the fact that $\psi$ vanishes at the bottom surface, and the contributions from opposite side walls cancel out each other under the doubly periodic assumption. For a smooth conducting plane subjected to the same incident wave, we assume the well-known exponential decrease of $\psi$ w.r.t. the penetration depth

$$
\psi(\bar{r}) = \psi_0 \exp(k_2 z)
$$

where $\psi_0$ is the value of $\psi$ at $z = 0$ and, based on (16), should be $2|\psi_{in}|$. In view of (19) and (20), the energy loss for the smooth-surface conductor is then given by $P_s = L^2/(2\delta)$.

C. Comparison With Vectorial EM Modeling

The rigorous surface-integral formulation based on EM theory of rough-surface scattering from penetrable objects can be found in a number of literature, e.g., [22]. The surface is generally discretized by RWG triangular elements, each of which is associated with two vectorial unknowns, usually the electric and magnetic surface-current densities. The size of the resultant matrix equation, if converted to corresponding scalar equations, is roughly $6N \times 6N$, where $N$ is the number of discretized triangular patches. If the low-frequency problem is taken into account, the common remedies, e.g., high-order basis function or high-order operator, will significantly increase the computational cost. In contrast, SWM gives a matrix with size of only $2N \times 2N$, leading to a significant reduction in solution time and memory storage. Since no hypersingular operator, i.e., second derivative of Green’s function, appears in (6), the SWM formulation is free of the involved low-frequency problem and, thus, avoids the excessive complexity introduced by the corresponding remediation. In addition, SWM also enjoys much simpler implementation and less overhead than EM modeling.

To validate the usage of SWM to approximate vector wave model, a recently developed EM wave model, called current and charge IE (CCIE) [23], is implemented to compute the loss-scaling factor. CCIE avoids the low-frequency breakdown by using electric- and magnetic-charge densities as unknowns, in addition to the traditional surface current densities, i.e., the unknown vector is $[\vec{e} \cdot \vec{E}, \vec{n} \times \vec{E}, \vec{n} \times \vec{H}, \mu \vec{n} \cdot \vec{H}]^T$. CCIE also leads to well-balanced systems for a wide frequency range by a dedicated normalization scheme, which renders it a suitable verification benchmark for SWM. The system of equations are established based on the electric field integral equation (EFIE) and magnetic field integral equation (MFIE) using the periodic Green’s function. The vector surface-current densities $(\vec{n} \times \vec{E}, \vec{n} \times \vec{H})$ are expanded with the RWG basis functions, and the scalar charge densities $(\vec{e} \cdot \vec{E}, \vec{n} \cdot \vec{H})$ use piecewise constant-basis functions. Once the surface-current densities are solved, the ohmic loss in the conductor is computed by

$$
\frac{1}{2} \int \int \operatorname{Re}\left\{ \frac{\vec{n} \times \vec{E}(\bar{r}) \cdot (\vec{n} \times \vec{H}^*(\bar{r}) \times \vec{n})}{\sqrt{f_z^2 + f_k^2 + 1}} \right\} \, dr
$$

In numerical experiments, SWM and CCIE are both employed to compute the frequency-dependent loss-scaling factors for an individual rough surface generated with Gaussian CF ($\sigma = \eta = 1 \, \mu m$) and discretized by triangular elements with interval of $\eta/8$. For a fair comparison, both SWM and CCIE use direct solver for the solution of matrix equations. As seen in Fig. 4, SWM provides a fairly reasonable approximation to the results from vector-wave modeling. The CPU times of SWM and CCIE are shown in Table I with different problem sizes. It can be seen that SWM is more than 60× faster than CCIE, which can be attributed to its much smaller problem size and less overhead.

<table>
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<th>CCIE (sec)</th>
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<tr>
<td>$\eta/6$</td>
<td>1800</td>
<td>8.12</td>
<td>541.44</td>
<td>67X</td>
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<tr>
<td>$\eta/8$</td>
<td>3200</td>
<td>19.72</td>
<td>1382.01</td>
<td>70X</td>
</tr>
<tr>
<td>$\eta/10$</td>
<td>5000</td>
<td>30.55</td>
<td>2921.38</td>
<td>74X</td>
</tr>
</tbody>
</table>
D. Spectral SSCM

Equation (15) is solved only for a deterministic surface, i.e., the surface heights and surface derivatives must be explicitly given. If the surface roughness is modeled by a stochastic process described in Section II, (15) becomes a stochastic IE w.r.t. the N correlated random variables of surface height

$$Z(\bar{h}) J(\bar{h}) = J_m(\bar{h}), \quad \bar{h} = (h_1, h_2, \ldots, h_N). \quad (22)$$

MC simulation is widely used to solve (22) and, thus, the rough-surface loss, by randomly sampling the solution space. However, the number of samples might be prohibitively large to guarantee convergence, e.g., 5000 sampling points may be needed for convergence to within 1%. An efficient solver for stochastic equation like (22) has been proposed in [4] that computes the statistical model of surface unknown $J$ via a modified polynomial-chaos expansion and Neumann expansion. Nevertheless, introduction of stochastic expansion to individual matrix elements in an equivalent sense modifies the inherent structure of the system matrix and prevent the potential numerical-acceleration techniques working exclusively for ordinary systems. Moreover, as the calculation of rough-surface loss involves internal interaction between the subvectors of $J$ [cf. (19)], it is not straightforward to recover the statistical model of final rough-surface loss from that of $J$, as the statistics of the product of two correlated stochastic processes is much more complicated than that of a single one.

In view of the aforementioned difficulties and the fact that there are efficient ways to solve the regular IE for each deterministic surface sample, we choose to apply the spectral SSCM [12] to compute the statistical model of rough-surface loss. SSCM is free of the aforementioned difficulties owing to its “sampling” nature, which does not alter the basic solution mechanism in each individual solution [24]. The essence of SSCM is to model the solution of stochastic IE as the homogeneous chaos (HC) expansion

$$P_r(\xi) \approx \sum_{|\mathbf{i}|=0}^{k} a_{i_1, \ldots, i_D} H_{i_1, \ldots, i_D}(\xi) \quad (23)$$

where $\xi$ is a set of independent random variables of D-length decorrelated from the original surface heights $\bar{h}$ by the Karhunen–Loeve (K–L) expansion. The stopping criteria of K–L expansion is that the ratio between the sum of the first $D$ largest eigenvalues and that of all the eigenvalues of the CF is larger than a user-defined value $\eta/\mu$, and that of all the eigenvalues of the CF is larger than a user-defined value $\eta/\mu$. Here, $H_{i_1, \ldots, i_D}(\xi)$ is a D-variable polynomial chaos constructed according to the PDF of $\bar{h}$ [25], which, for Gaussian PDF, is a Hermite polynomial, and $|\mathbf{i}| = i_1 + \cdots + i_D$. Note that in (23) $k = 1$ corresponds to the first-order modeling, and $k = 2$ refers to the second-order modeling which is sufficient for most physical processes. The coefficients of the HC expansion are determined by the D-dimensional infinite integration

$$a_{i_1, \ldots, i_D} = \int_{-\infty}^{+\infty} d^D \xi P_r(\xi) H_{i_1, \ldots, i_D}(\xi) \text{PDF}(\xi) \quad (24)$$

which can be efficiently computed by the sparse-grid (SG) quadrature [26]. Once the HC coefficients are determined, the common statistical quantities, mean and variance, of $P_r$ can be easily calculated by

$$\text{Var}(P_r) = \sum_{|\mathbf{i}|=1}^{k} a_{i_1, \ldots, i_D}^2 \langle (H_{i_1, \ldots, i_D})^2 \rangle$$

where $\langle (H_{i_1, \ldots, i_D})^2 \rangle = \int_{-\infty}^{+\infty} d^D \xi H_{i_1, \ldots, i_D}(\xi) \text{PDF}(\xi)$. The major computational cost of SSCM lies in the solution of (15) for the sampling points selected by SG quadrature, to which the aforementioned efficient linear solvers are applicable. Compared with MC simulation, SSCM can achieve a second-order accuracy with much fewer sampling points.

IV. NUMERICAL RESULTS

In the following numerical experiments, we assume a conductor with resistivity $\rho = 1.67 \mu \Omega \cdot \text{cm}$ and a dielectric with relative permittivity 3.7 of common silicon dioxide ($\epsilon_1 = 3.7 \times 8.854 \times 10^{-12}$). The periodic length $L$ is 5µ, and the discretized interval is $\eta/8$. The loss-scaling factors used for comparisons with closed-form models are their mean values computed by SSCM using $r = 0.95$ in K–L expansion. All programming and simulation were done with Matlab on a 2.4-GHz 2-Gb-RAM PC.

A. Comparison With SPM2

We first compare SWM with SPM2 which is known to be accurate for small roughness while invalid for large roughness. In Fig. 5, results of SWM and SPM2 are shown for Gaussian CF with various levels of roughness, i.e., $\sigma$ is fixed at 1 µm, while $\eta$ varies from 1 to 3 µm. For the smoothest case ($\eta = 3$ µm), the two methods are in almost perfect match. The deviation, however, gradually grows as the degree of roughness increases and becomes significant for the roughest case of $\eta = 1$ µm. We
Fig. 6. Influence of the choice of periodic length (Gaussian CF with $\sigma = 1 \mu m$, $\eta = 2 \mu m$).

We also plot the results from the empirical Hammerstad formula (1). As expected, (1) cannot differentiate these distinct cases as they all have the same $\sigma$. The effect of using different periodic lengths is shown in Fig. 6 with Gaussian CF, which justifies the selection of $L$.

We further compare SWM with SPM2 using the CF

$$C(d) = \sigma^2 \exp \left\{ -\frac{d}{\eta_1} \left[ 1 - \exp \left( -\frac{d}{\eta_2} \right) \right] \right\}$$

(26)

extracted from practical measurement [13]. A surface generated with CF (26), which is illustrated in Fig. 7, is also continuous as $C'(0) = 0$, which implies that the surface will turn out to be smooth if sufficiently zoomed in. The partial derivatives of the surface also exist due to the existence of the second-order derivatives of $C(d)$ at $d = 0$ [27]. It has been shown in [13] and [28] that under this roughness setting, SPM2 can give an accurate prediction of surface-roughness loss. The testing frequency is from 100 MHz to 10 GHz. As shown in Fig. 8, there is a good agreement between SWM and SPM2. The aforementioned two experiments suggest that SWM is accurate for small roughness cases. Note that HBM is not applicable for these scenarios as the skin depth generally exceeds the height of surface roughness.

To demonstrate the inapplicability of SPM2 for roughness with large slope, the loss-scaling factor is plotted w.r.t. varying $\sigma$ ranging from 1 to 3 $\mu m$ and varying the frequency ranging from 1 to 10 GHz. The Gaussian CF is used with the correlation length $\eta$ fixed at 2 $\mu m$. Fig. 9(a) shows that for large roughness (the right upper corner), the loss-scaling factors calculated by SPM2 can go beyond three, which is physically impractical. In contrast, Fig. 9(b) shows that SWM can correctly predict the saturation of loss-scaling factor for Gaussian rough surfaces.

B. Comparison With HBM

In order to verify the effectiveness of SWM under large roughness, we use the results from HBM as the benchmark, whose accuracy has been confirmed by practical measurements for a specific setting in high frequency [7]. Since the CF of randomly distributed hemispherical bosses is not easy to extract, we only compute the loss-scaling factor of a single deterministic half-spheroid located on a conducting plane with the parameters specified in [7]. The rms base radius $b$ of the half-spheroid, which is not explicitly given in [7], is set to be 2.45 $\mu m$. The triangular mesh of the half-spheroid and the remaining plane is shown in Fig. 10. The testing frequency ranges from 1 to 20 GHz in order to keep the skin depth small compared with the height of protrusion. Two types of discretization schemes, rectangular and triangular, are used with the same discretized interval set to be $\delta/5$ to model the rapid variation of the field inside the conductor. Simulation results are shown in Fig. 11. It can be observed that the two SWM curves track the trend of HBM and saturate at sufficiently high frequencies. The accuracy of the triangular discretization is better than that of the rectangular one while at the cost of doubling the number of unknowns. This comparison demonstrates that SWM remains valid for cases with large roughness and high frequencies. Despite the fact that a direct comparison with SPM2 is unavailable due to the difficulty in extracting spectral-density function, the validity of SPM2, in this case, is dubious as the rms height and surface slope are both large.
Again, to demonstrate the inapplicability of HBM for small roughness/low frequencies, the loss-scaling factor is plotted w.r.t. varying $\sigma$ ranging from 1 to $3 \mu m$ and varying frequency ranging from 0.1 to 1 GHz. Single half-spheroid modeling is used with $L = 9.4 \mu m$ and $b = 2.45 \mu m$. Fig. 12(a) shows that for small roughness/low frequencies, HBM predicts erroneous loss-scaling factors that are less than 1 and should be replaced by other closed-form models, e.g., the Hammerstad formula [7]. In contrast, Fig. 12(b) shows that the loss-scaling factor calculated by SWM are all larger than 1. It is worth noting that the major factors that limit the validity of SPM2 and HBM have different emphases. The former is largely related to the geometrical properties of the roughness under investigation, while the latter relies more on the frequency range that the simulation is conducted. Similar conclusion can be drawn for other analytical techniques. Therefore, it is not a trivial task to select the most appropriate models for a given problem, particularly when generic wideband simulation is considered.

One important advantage of SWM is that it can be used for fast verification of the accuracy of closed-form techniques under specific scenarios. A good example is that, in HBM, a spheroid is actually transformed into an equivalent hemisphere with the same volume [7], since the analytical solution is only available for a hemisphere. Such transformation, however, will inevitably incur an accuracy loss. Fig. 13 shows the loss-scaling ratios calculated by SWM and HBM for three half-spheroids with different height-to-base ratios but the same volume $\pi L^3/128$. It can be seen that HBM treats the three cases as the same, whereas SWM differentiates them correctly. This suggests that HBM is more appropriate for roughness with even shapes and may fail for roughness with either very large or small height-to-base ratios. This example also demonstrates the usefulness of an efficient numerical-simulation methodology in verifying the accuracy of closed-form techniques without resorting to expensive experimental measurements.

As reported in [6], the loss-scaling factor for a 3-D rough surface is much higher than that of a 2-D one with the same degree of roughness. Fig. 14 compares the 3-D SWM with a simplified 2-D SWM formulation where the surface height is uniform along $y$-axis. The results also confirm a significant increase of loss with 3-D roughness over 2-D roughness, thereby justifying the necessity of 3-D consideration for roughness analysis.

**C. Stochastic Analysis With SSCM**

To verify the accuracy of the statistical model constructed by SSCM, Fig. 15 shows the cumulative distribution function
Fig. 12. Loss-scaling factor w.r.t. roughness ($\sigma = 1 \sim 3 \mu m$) and frequency ($f = 0.1 \sim 1$ GHz) for half-spheroid modeling ($L = 9.4 \mu m, b = 2.45 \mu m$).

Fig. 13. Power-loss ratios for half spheroids with different $h$ and $b$ ($L = 9.4 \mu m$).

Fig. 14. 3-D SWM versus 2-D SWM for Gaussian CF ($\sigma = 1 \mu m, \eta = 2 \mu m$).

Fig. 15. CDF of $P_r/P_s$ ($\sigma = 1 \mu m, \eta = 2 \mu m, f = 5$ GHz).

(CDF) of the loss-scaling factor calculated by first- and second-order SSCM. The surface is of Gaussian CF with $\sigma = 1 \mu m$, $\eta = 2 \mu m$, and $f = 5$ GHz. Results from MC simulation with 5000 sampling points are used as the benchmark. It can be seen that second-order SSCM is necessary and sufficient to model the distribution of loss-scaling factor under random surface roughness. Tables II and III give the corresponding mean and variance of loss-scaling factors for rough surfaces with different $\eta$’s, which also demonstrates the improvement of accuracy resulting from second-order SSCM. The number of sampling points of SSCM w.r.t. to different accuracy in K–L expansion is tabulated in Table IV for Gaussian CF ($\sigma = 1 \mu m, \eta = 2 \mu m$). It shows that SSCM can offer a significant reduction in the amount of sampling points compared with the MC simulation.
Several remarks are in order:

1) The proposed SWM approach significantly expands the valid range compared with existing analytical techniques like SPM2 and HBM and, thus, enables a generic simulation for different surface roughness over a wide frequency range. It also offers an efficient and convenient way to test the validity of other closed-form techniques without resorting to costly experimental verification.

2) Compared with rigorous EM wave modeling, SWM leads to remarkable computational savings by reducing the number of unknowns and using low-order basis function. In addition, SWM avoids the low-frequency problem that is difficult to handle in EM modeling and, thus, the subsequent expense on correction measures.

3) Complete statistical model of loss-scaling factor beneficial for further stochastic processing is available with SWM. The increased computational cost from random-surface modeling has been well alleviated by the application of SSCM, by which, much fewer sampling points than MC simulation are needed to achieve a satisfactory second-order accuracy.

4) For rough surface with exponential CF, the major difficulty in simulation arises from the gradient discontinuity of \( C_e(d) = \sigma^2 \exp(-|d|/\eta) \) at \( d = 0 \), which indicates that the surface includes short-length variations down to an arbitrarily small scale, and, as a result, the surface derivatives do not exist. However, in practice, the observation of fine-scale roughness is restricted by the limit of measurement tools and the required modeling accuracy. In this sense, an exponential surface can be viewed as “piecewise continuous” between any two adjacent sampling points provided that the inherent exponential statistics of the surface is properly captured by such sampling, which suggests a viable solution to modeling exponential roughness, e.g., [29].

V. CONCLUSION

The main contribution of this paper has been the development of a generic and efficient methodology SWM for the simulation of rough-surface loss in interconnects and packagings. The key idea is to approximate the complicated EM wave problem with a simplified scalar-wave problem. The major merits of SWM are twofold. First, the significantly enhanced simulation capacity and flexibility eliminate the need of undesirable model selections and model switches and the need of expensive experiments for verifying closed-form techniques. Second, the availability of statistical model in terms of independent random variables is achieved efficiently using SSCM, which in turn enables further stochastic analyses. The excellent applicability of SWM has been verified by benchmarking against a rigorous EM implementation as well as existing closed-form techniques, namely, SPM2 and HBM, in their respective valid regions.

### APPENDIX

The derivation of (9) is given as follows:

\[
\begin{align*}
\bar{E}_t &= -\hat{n} \times (\hat{n} \times \hat{E}) \\
&= -\hat{n} \times \left[ \frac{1}{j \omega \varepsilon} \hat{n} \times (\nabla \times (\hat{i}_H \psi)) \right] \\
&= \frac{1}{j \omega \varepsilon} \hat{n} \times \left[ \psi \hat{n} \times (\nabla \times \hat{i}_H) + \nabla \psi \times \hat{i}_H \right] \\
&= \frac{1}{j \omega \varepsilon} \hat{n} \times \{ \nabla (\psi \hat{n} \times \hat{i}_H) - \hat{i}_H (\hat{n} \cdot \nabla \psi) \} \\
&= \frac{1}{j \omega \varepsilon} \{ \hat{i}_E \| \nabla \psi \times \hat{n} \cdot \nabla \psi \} \\
&= \hat{i}_E \left[ \frac{1}{j \omega \varepsilon} (\nabla \psi - \hat{n} \cdot \nabla \psi) \right] \\
&= \hat{i}_E \left[ \frac{1}{j \omega \varepsilon} (\nabla \psi - \hat{n} \cdot \nabla \psi) \right] \\
\end{align*}
\]

where the fourth equality results from the vector triple product and the fifth equality is due to \( \hat{n} \cdot \hat{i}_H = 0 \). The components of \( \hat{i}_H \) are determined by the following relationship:

\[
\begin{align*}
-f_x t_{Hx} - f_y t_{Hy} + t_{Hz} &= 0 \\
f_y t_{Hy} + f_x t_{Hx} &= 1 \\
t_{Hz} &= \tan(\theta) t_{Hx}
\end{align*}
\]

where \( \theta \) denotes the azimuth angle of incident field, \( \psi \) can be chosen arbitrarily provided the rough surface is isotropic, and, for simplicity, it can be set as 0.

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### REFERENCES


